

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Young-Kwan Lee, <i>et al.</i>
Serial No. - Pending	Filing Date: January 27, 2004
Title of Application:	Antenna Structure For Inductively Coupled Plasma Generator

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents enclosed).

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
	376/123	5,289,509	1994	Moeller
Foreign Patent Documents				
Exam. Initials	Document No.	Date	Country	
	1 079 671	2001	EP	
	2000-323298	2000	JP (with English abstract)	
	2000-048998	2000	JP (with English abstract)	

The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

Respectfully submitted,

January 27, 2004

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Date Considered

Examiner